

2851



In re Application of:

Akihiro NAKAUCHI, et al.

Application No.: 09/845,297

Filed: May 1, 2001

For: PROJECTION EXPOSURE APPARATUS
HAVING ABERRATION MEASUREMENT
DEVICE

Docket No. 00862.022217

Examiner: A. Mathews

Group Art Unit: 2851

Date: September 5, 2003

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TECHNOLOGY CENTER 2800

THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	15	MINUS	55	= 0	x \$9 \$18	0.00
INDEP. CLAIMS	1	MINUS	20	= 0	x \$42 \$84	0.00
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						0.00

☐ Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$_____ is enclosed.

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☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

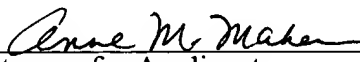
☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.

☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Anne M. Maher
Registration No. 38,231

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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00862.022217

PATENT APPLICATION

#11/B
9-16-03
JPR

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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AMENDMENT AND LETTER SUBMITTING SUBSTITUTE
SPECIFICATION IN RESPONSE TO EX PARTE QUAYLE

Sir:

In response to the Office Action dated July 7, 2003, in the above-identified
application, please amend the application as follows:

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INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Amendment Practice of 37 C.F.R. 1.121 - Final Rule effective July 30, 2003. Prosecution was closed in accordance with the practice under *Ex Parte Quayle*, 195 CD 11; 453 OG 213. To comply with the requirement made in the Official Action, and in accordance with 37 C.F.R. 1.125(a), Applicants are providing both a marked-up version and a clean version of the substitute specification. No new matter has been added. Applicants are also cancelling non-elected Claims 16-55, as required.